

2017 TCL meeting agenda

Time	Item	
08:30 – 09:45	Welcome	Chairperson
08:45 – 09:00	Introduction	All
09:00 – 09:10	Additions to and adoption of agenda	All
09:10 - 09:30	Minutes of previous meeting	Secretary
09:30 – 10:30	<p>Comparisons</p> <ul style="list-style-type: none"> • Gauge blocks by interferometry CK 1, NMISA as pilot, Artefacts still problem • Gauge blocks by comparison, Egypt as pilot, update. • Line scale LS7, update • Micrometers, Verniers and Dial Test Indicators (DTIs), LS5. What are our plans around it? <p>Any other comparisons? Training: Can we plan some training courses? In what fields?</p>	All
10:30 – 11:00	Tea break	
11:00 – 11:45	<p>R&D activities;</p> <ul style="list-style-type: none"> • NIS and NMISA are working on a joint project on a Double ended interferometer. • CT Scanner • Surface texture • Any other R&D projects with any other countries which we can identify? 	All
11:45-13:00	Activities from NMIs	All
13:00 – 14:00	Lunch	
14:00 -15:00	<p>CMC review report CMC submission and review: Currently NMISA are in the process of submitting new CMCs. The review must be done in accordance to: Version AFR-11-009d attached a document which we as TCL drew up a few years ago for the review of CMCs. I think it a bit too detailed but we must agree on a version.</p>	Chairperson
15:30 – 16:00	Tea Break	
16:00 – 17:00	<p>CCL feedback and news General discussions</p>	All